

**Electronic Filing System (EFS) Data**  
**Electronic Patent Application Submission**  
**USPTO Use Only**

EFS ID: 65350

Application ID: 10710653



Title of Invention: PRESSURE ASSISTED WAFER  
HOLDING APPARATUS AND  
CONTROL METHOD

First Named Inventor: David Bain

Domestic/Foreign Application: Domestic Application

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U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICE  
FEE RECORD SHEET

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